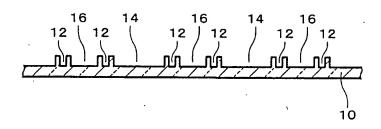
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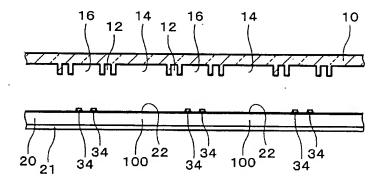
### FIG.1 (A)

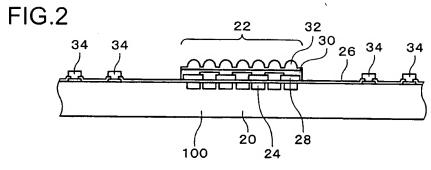


### FIG.1 (B)



### FIG.1 (C)





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FIG.3 (A)

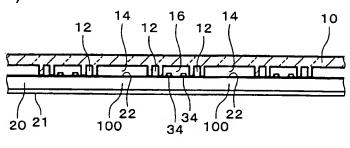
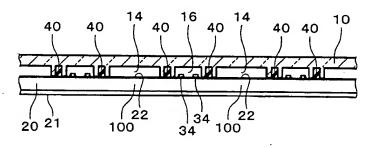
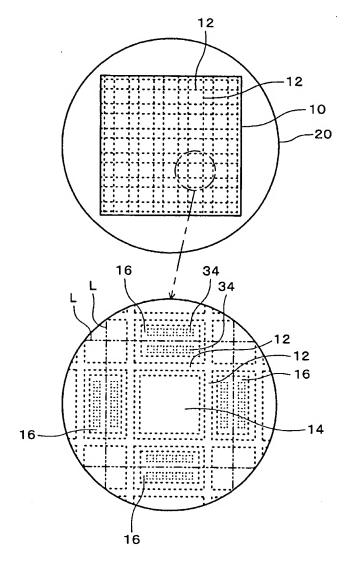


FIG.3 (B)



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FIG.5 (A)

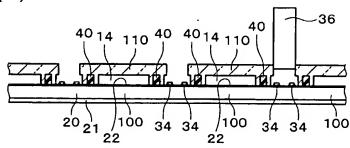


FIG.5 (B)

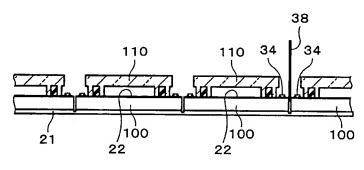
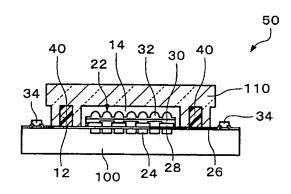


FIG.6



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### FIG.7 (A)

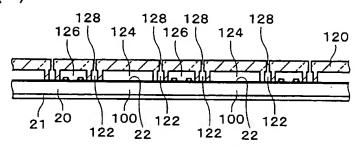


FIG.7 (B)

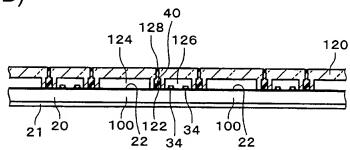
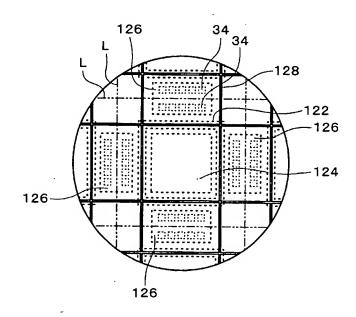
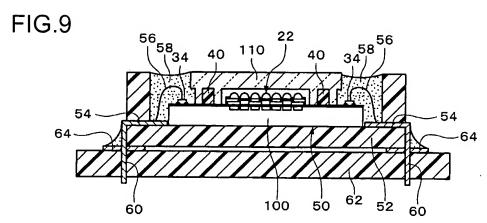
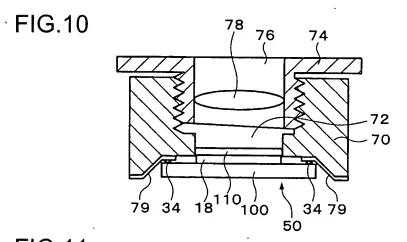


FIG.8

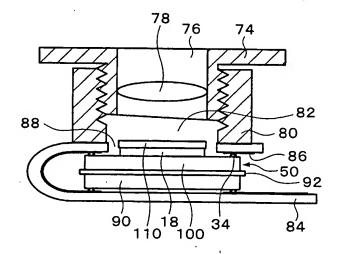


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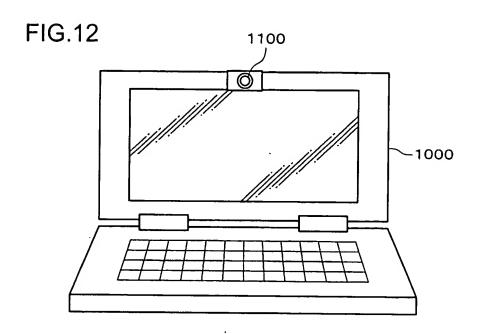
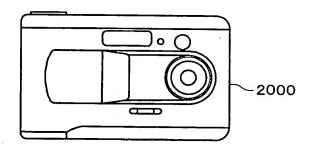


FIG.13



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